



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICANT(S): Kunihiro Take      ATTY DOCKET NO. 09792909-4718  
SERIAL NO. 09/732,393      GROUP ART UNIT: 2623  
FILING DATE: December 7, 2000      EXAMINER: V. Kibler  
INVENTION: "SEMICONDUCTOR WAFER EXAMINATION SYSTEM"

ENTERED  
9/13/04  
Per filing of  
RCE (8-2-04)  
mail

AMENDMENT "B" AFTER FINAL

Mail Stop: Box After Final Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Technology Center 2600

*Do not enter US 5/25/04*

SIR:

This amendment is filed in response to the Final Office Action of January 30, 2004. Please reconsider the application in view of the amendment and remarks presented below.

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AFTER FINAL AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 30, 2004.

Mary Ann Smolucka